

Application/Control No.	Applicant(s)/Patent under Reexamination
10/708,891	KITAMURA, SATOSHI
Examiner	Art Unit
Lee Lum	3611

	SEAR	CHED	
Class	Subclass	Date	Examiner
RES	EARCH	4	
		12/1/0	sh
			$\cup \cup$

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
	<u> </u>			
		<u>. </u>		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
·		
•		